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By:

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**PATENT
Box RCE**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re: Nanning J. Arfsten, *et al.* : Group Art Unit 1775
Conf. No.: 8672 :
Appln. No. 09/437,948 : Examiner: J. McNeil
Filed: November 10, 1999 :
For: NIOBIUM OXIDE-BASED LAYERS : Attorney Docket
FOR THIN FILM OPTICAL : No. 275-3US
COATINGS AND PROCESSES FOR
PRODUCING THE SAME :

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

It is requested that the references listed on the attached Information Disclosure Citation Form PTO/SB/08A be considered by the Patent Examiner in connection with the above-identified application and be made of record therein.

Independent consideration and acknowledgment of the listed references are respectfully requested.

Respectfully submitted,

NANNING J. ARFSTEN, *ET AL.*

April 7, 2003
(Date)

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